

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV. 8-83) PATENT AND TRADEMARK OFFICE						ATTY. DOCKET NO. 29131.0217		SERIAL NO. Not Yet Assigned	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)						APPLICANT Fruitman, Clinton O.			
						FILING DATE January 16, 1998		GROUP ART UNIT Unknown	
U. S. PATENT DOCUMENTS									
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE		
FOREIGN PATENT DOCUMENTS									
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION		
							YES	NO	
	A	EP O 348757 A2	01/03/90	Europe			X		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)									
EXAMINER					DATE CONSIDERED				
					6/29/98				
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SERIAL NO.
09/008.148

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Fruitman, Clinton O.

APPLICANTS

FILING DATE

January 16, 1998

GROUP ART UNIT

NYA


U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Bajaj, R. et al., Materials Research Society Symposium Proceedings, Vol. 337, "Effect of Polish Pad Material Properties on Chemical Mechanical Polishing (CMP) Processes, 4/4/94, pages 637-644.

EXAMINER

DATE CONSIDERED

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